



Response Under 37 C.F.R. § 1.116
Group Art Unit 2815, Expedited Procedure

03500.013630.

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)

MASAAKI IWANE ET AL.)

Application No.: 09/346,678)

Filed: July 2, 1999)

For: CRYSTAL GROWTH PROCESS,)
SEMICONDUCTOR DEVICE,)
AND ITS PRODUCTION)
PROCESS)

Examiner: J. Diaz

Group Art Unit: 2815

February 28, 2003

Commissioner for Patents
Box AF
Washington, D.C. 20231

#25/Amendment
@11/2/02
ANDREW J. HARRIS
3/3/03
Surles
4/9/03

TECHNOLOGY CENTER 2800

MAR - 6 2003

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AMENDMENT AFTER FINAL REJECTION

Sir:

In response to the Office Action dated December 3, 2002, please amend the
above-identified application as follows pursuant to 37 C.F.R. 1.116: